

IFW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2826  
Examiner: Feifei Yeung Lopez

In Re PATENT APPLICATION Of:

Applicant(s): Mineo MIURA )  
Serial No.: 10/588,103 )  
Filed: July 31, 2006 )  
For: SEMICONDUCTOR DEVICE AND )  
METHOD FOR MANUFACTURING )  
THE SAME )  
Docket No.: AI 420NP )

**AMENDMENT**

\_\_\_\_\_  
April 22, 2009

**Mail Stop Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Examiner's Action mailed on January 22, 2009, please amend  
the above-identified application as follows:

**FEE ENCLOSED: \$**       
Please charge any further fee to  
our Deposit Account No. 18-0002